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U.S. PATENT DOCUMENTS										
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	OTHER DOCUMENTS (Include	ling Author,	Γitle, Date, Pertinent Pages, etc.)		7-2					
la	J. Tominaga et al., "An approach for recording and readout beyond the diffraction limit with an Sb thin film", Applied Physics Letter, Vol. 73, No. 15, 1998, pp. 2078-2080									
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EXAMINER Cin Clu Date considered 6/25/03										
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